



Application No.: 09/943,955

PATENT/OFFICIAL

Docket No.: 5918/FPS/MMCS/APC/DV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

SHANMUGASUNDRAM et al.

Serial No. 09/943,955

Group Art Unit: 1765

Filed: August 31, 2001

Examiner: L.T. Umez Eronini

For: FEEDBACK CONTROL OF CHEMICAL MECHANICAL POLISHING DEVICE  
PROVIDING MANIPULATION OF REMOVAL RATE PROFILES

CERTIFICATION UNDER 37 C.F.R. § 1.8(a)

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6/24/2005

REPLY AFTER FINAL REJECTION

Sir:

This Reply is responsive to an Office Communication dated December 30, 2004, and is accompanied by a petition for a three month extension of time to extend the period of response up to and including June 30, 2005.

Amendments to the Claims are reflected in the listing of claims begins on page 2.

Remarks/Arguments begin on page 11 of this paper.